

Mechanical Properties of Air Plasma Sprayed Environmental Barrier Coating (EBC) Materials

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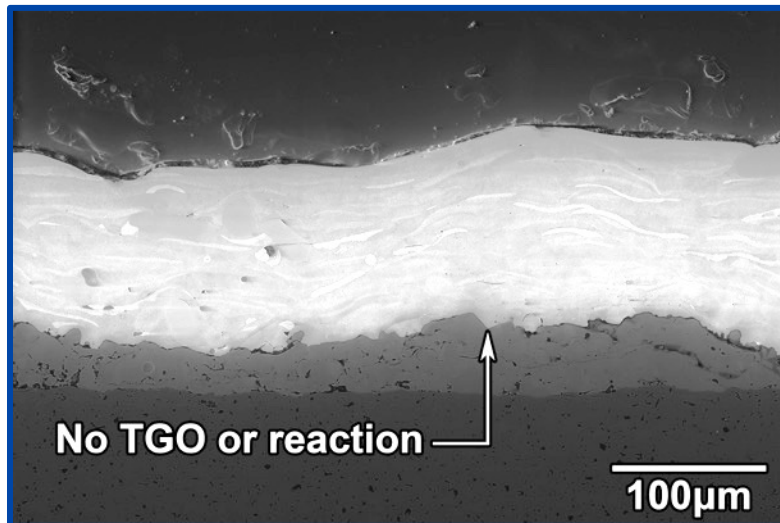


Outline: testing of relevant mechanical properties of APS EBCs: $\text{Yb}_2\text{Si}_2\text{O}_7$ and Si

1. Very brief introduction
2. Methodology
3. APS $\text{Yb}_2\text{Si}_2\text{O}_7$ properties
 1. APS structure
 2. Elastic modulus, flexure strength, K_{IC}
 3. Isothermal creep
 4. Laser thermal gradient creep
4. APS Si properties
 1. APS structure
 2. Elastic modulus, flexure strength, K_{IC}
 3. Laser thermal gradient creep
 4. Interlaminar/interfacial toughness

$\text{Yb}_2\text{Si}_2\text{O}_7/\text{Si}$ EBC Property Testing Goals

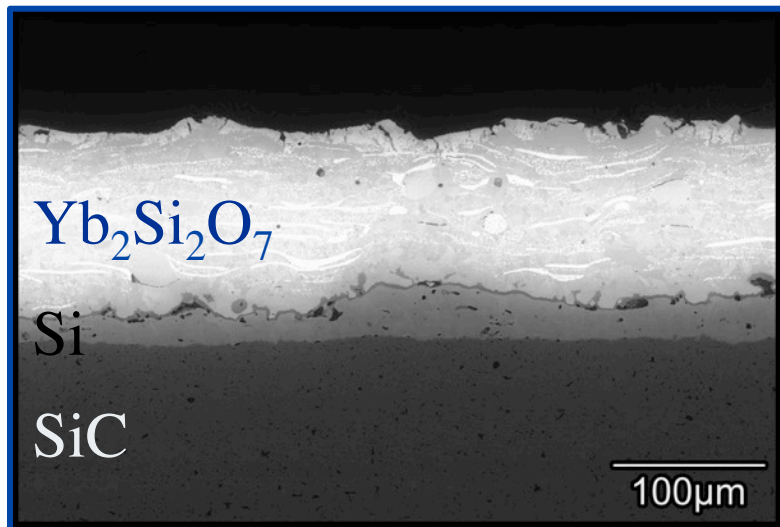
Annealed Coating



Provide insight into how APS processing can alter mechanical properties

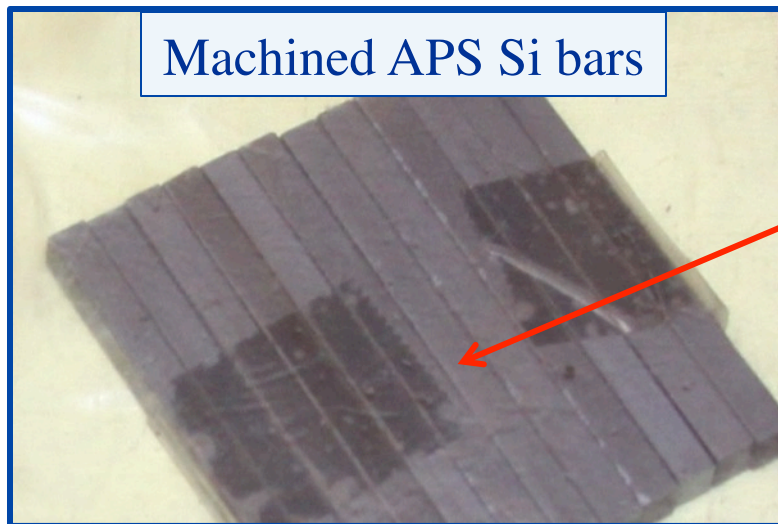
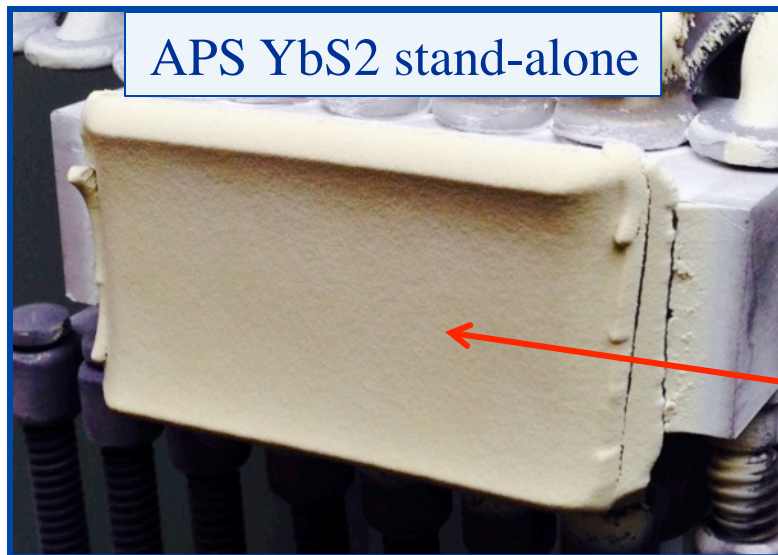
Provide thermophysical data for modeling efforts of EBC systems

2000 Steam Cycles



Understand mechanical properties of a relevant EBC system

Methodology



- Refine spray parameters
- Deposit APS stand-alone material:
 $\text{Yb}_2\text{Si}_2\text{O}_7$ and Si
@ 130 x 65 x 13mm
- Machine (grind) APS stand-alone material into test bars
15 YbS2 and and 15 Si
@ 50 x 5 x 4mm
- Test density, size, elastic modulus for all specimens
- Perform mechanical tests

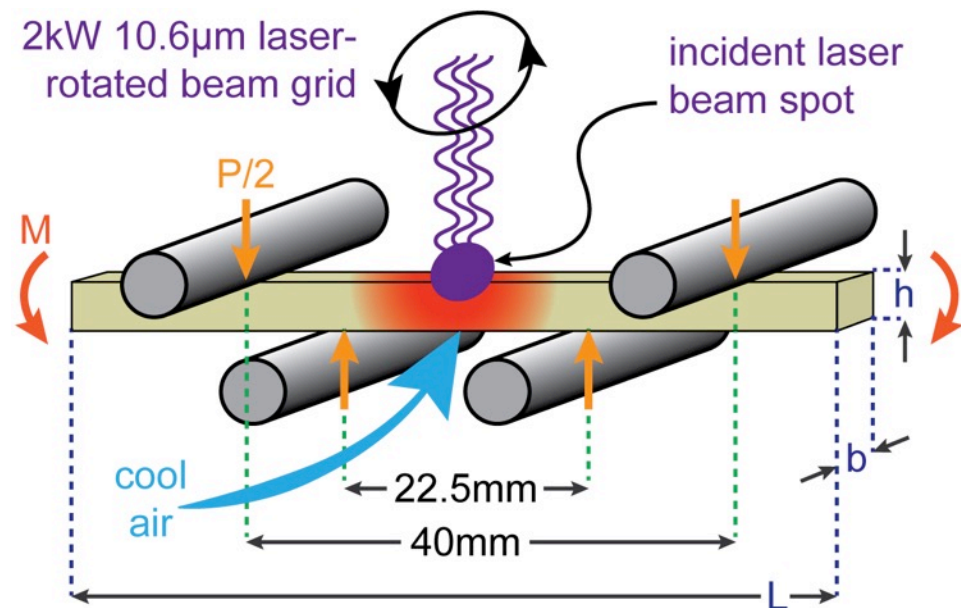
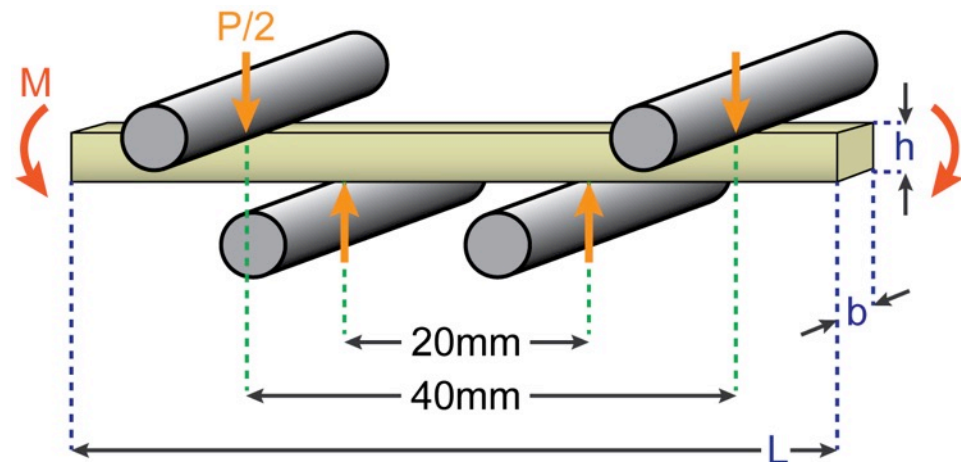
4pt flexure- isothermal & thermal gradient

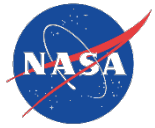
Convenient for determining many mechanical properties

Low temperature configuration (ASTM C1161)

High temperature configuration (ASTM C1211)

Laser/cooling air induced thermal gradient configuration





Creep Equations and Testing

Primary

$$d\varepsilon/dt = A * \exp(-E_a/RT) * \sigma^n * t^{-s}$$

key parameters **E_a , n , s**

Secondary

$$d\varepsilon/dt = C * \exp(-E_a/RT) * \sigma^n$$

key parameters **E_a , n**

Data recorded in creep test is actuator or mid-point displacement, load, and time. Models are used to calculate strain (see Hollenberg et. al. 1970).

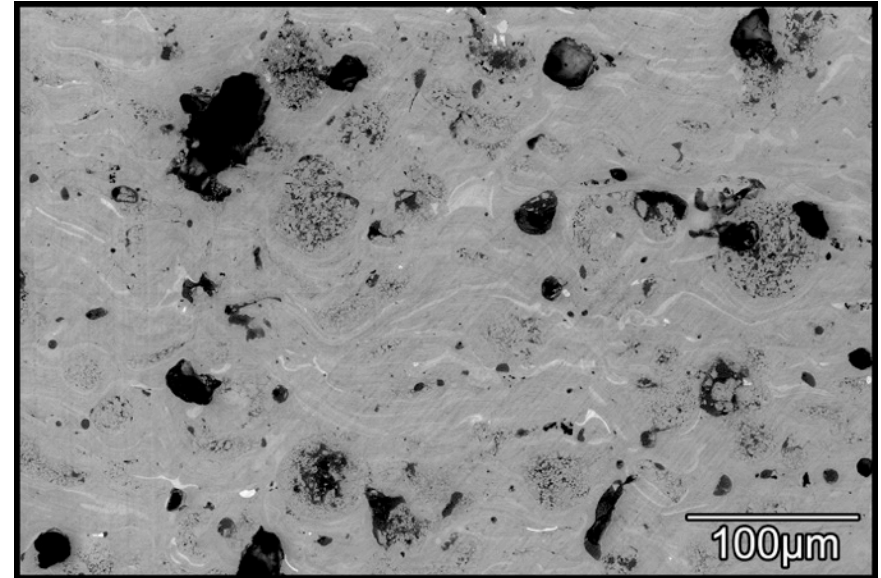
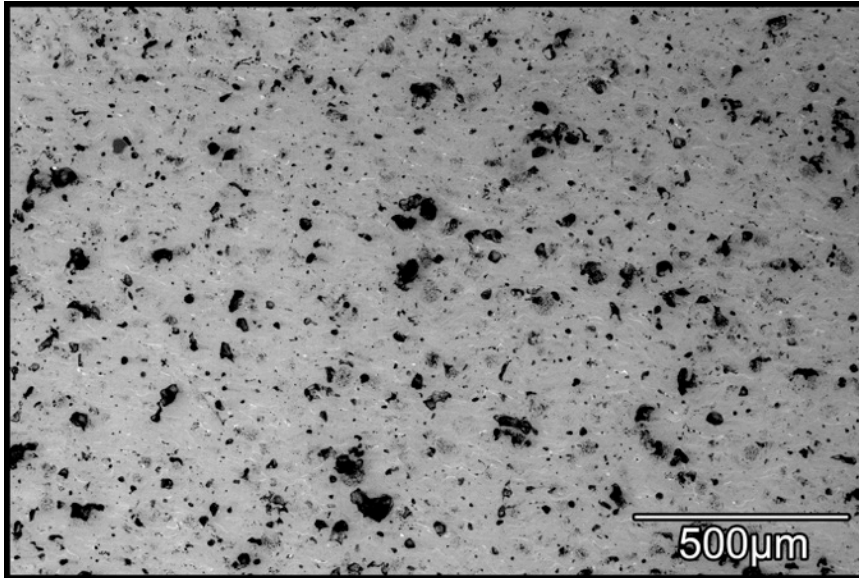
For low n (~ 1), elastic strains from Euler-Bernoulli beam theory happen to be accurate.



APS $\text{Yb}_2\text{Si}_2\text{O}_7$ Properties

Elastic Modulus, Flexure Strength, Toughness,
Isothermal Creep, Laser Thermal Gradient Creep

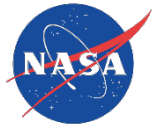
$\text{Yb}_2\text{Si}_2\text{O}_7$ Microstructure



APS structure crack-free and 90-91% dense
(archimedes density and image analysis)

Pores loosely spherical

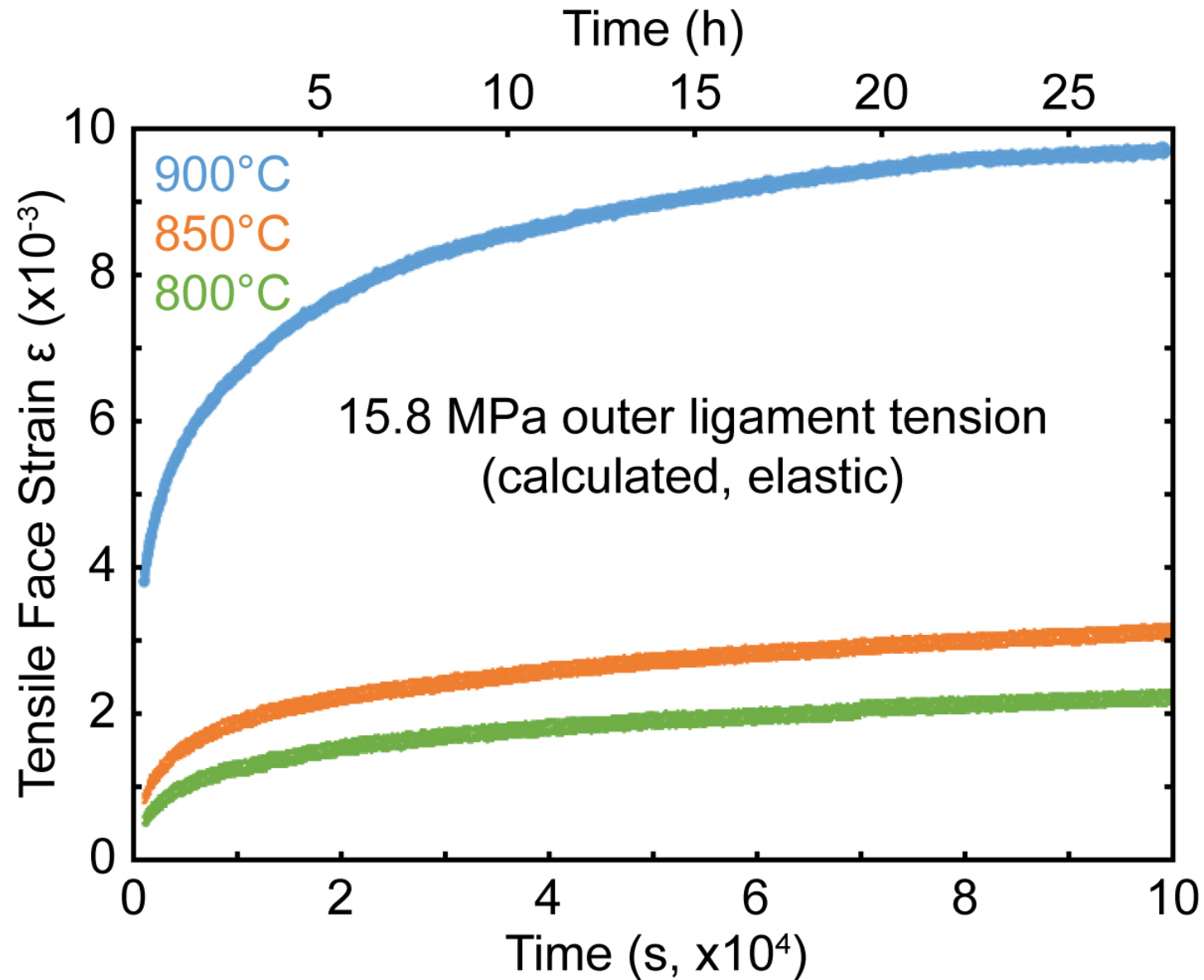
Some Si loss occurred during APS processing (quantity
still undetermined, pending analysis)

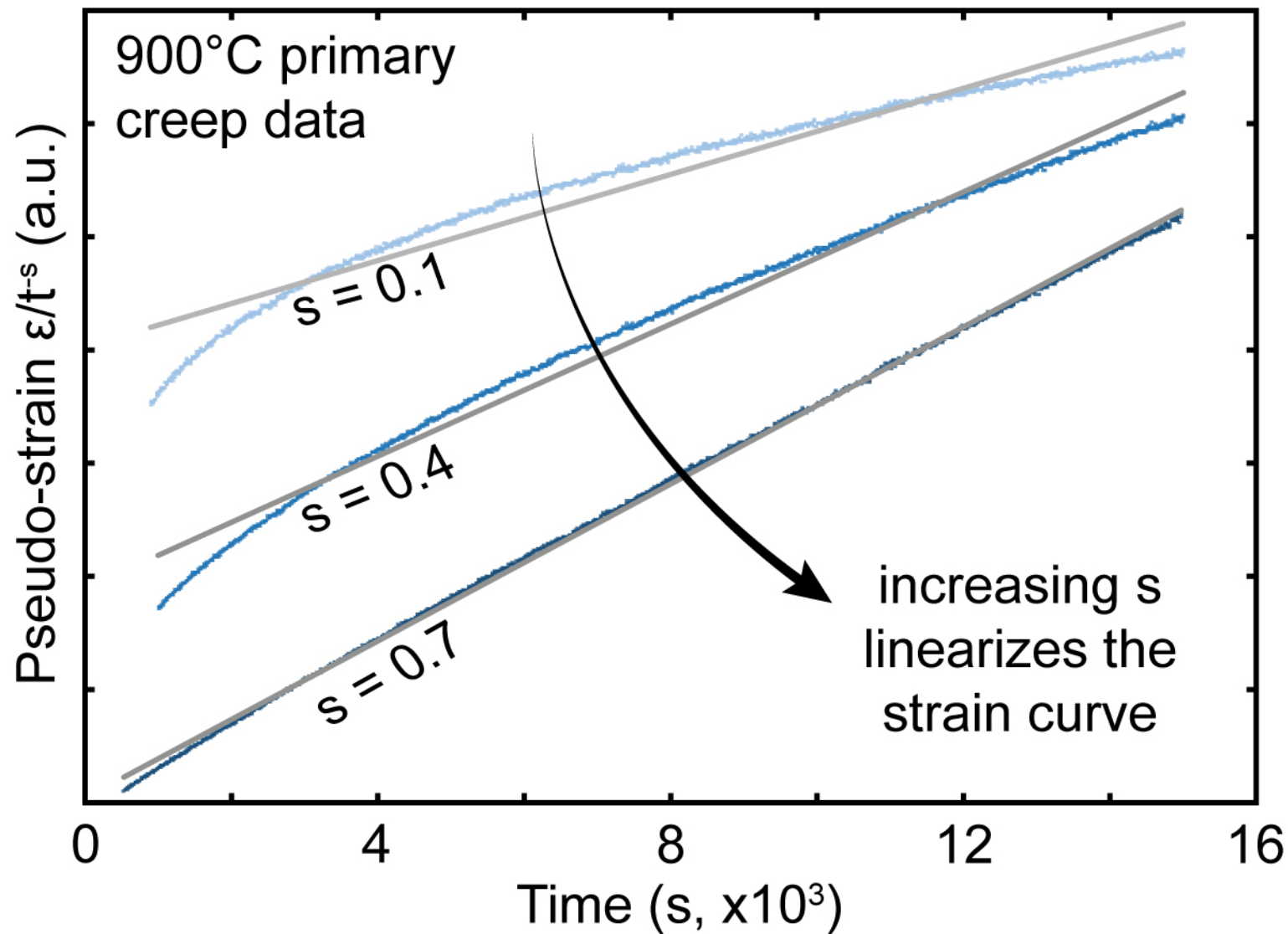


$\text{Yb}_2\text{Si}_2\text{O}_7$ Properties

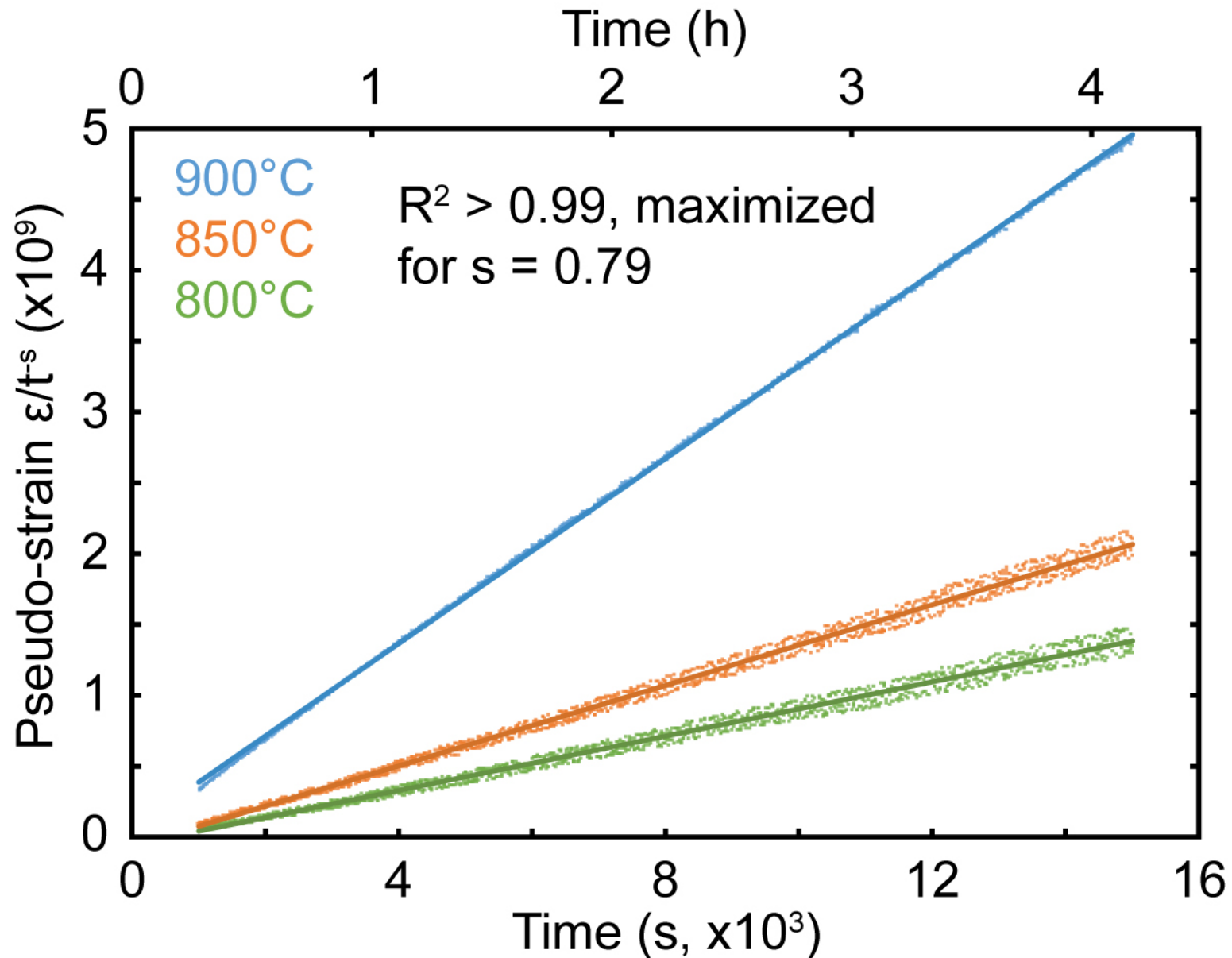
- Elastic Modulus- impulse excitation $E = 33.4 \text{ GPa}$, $\sigma = 2.53$
13 specimens @ 25°C
(~170-180GPa bulk: X-ray, nanoindentation)
- Low Temperature $K_{IC} = 0.925 \text{ MPa}\cdot\text{m}^{0.5}$, $\sigma = 0.05$
3 specimens @ 25°C
(dense material $2 \text{ MPa}\cdot\text{m}^{0.5}$)
- Low Temperature Flexure Strength = 19.7 MPa , $\sigma = 0.62$
4 specimens @ 25°C
(dense & stoichiometric: ~100MPa $\text{Yb}_2\text{Si}_2\text{O}_7$, ~15MPa Yb_2SiO_5)
- High Temperature Flexure Strength = 24.3 MPa , $\sigma = 0.42$
2 specimens @ 900°C

Isothermal Creep Behavior





Primary creep s parameter determination





Isothermal Creep Rates and E_a

Isothermal Secondary Creep Strain Rates @ 15.8 MPa:

$$d\varepsilon/dt = 3.39 \times 10^{-9} \text{ @ } 800^\circ\text{C}$$

$$d\varepsilon/dt = 5.63 \times 10^{-9} \text{ @ } 850^\circ\text{C}$$

$$d\varepsilon/dt = 1.23 \times 10^{-8} \text{ @ } 900^\circ\text{C}$$

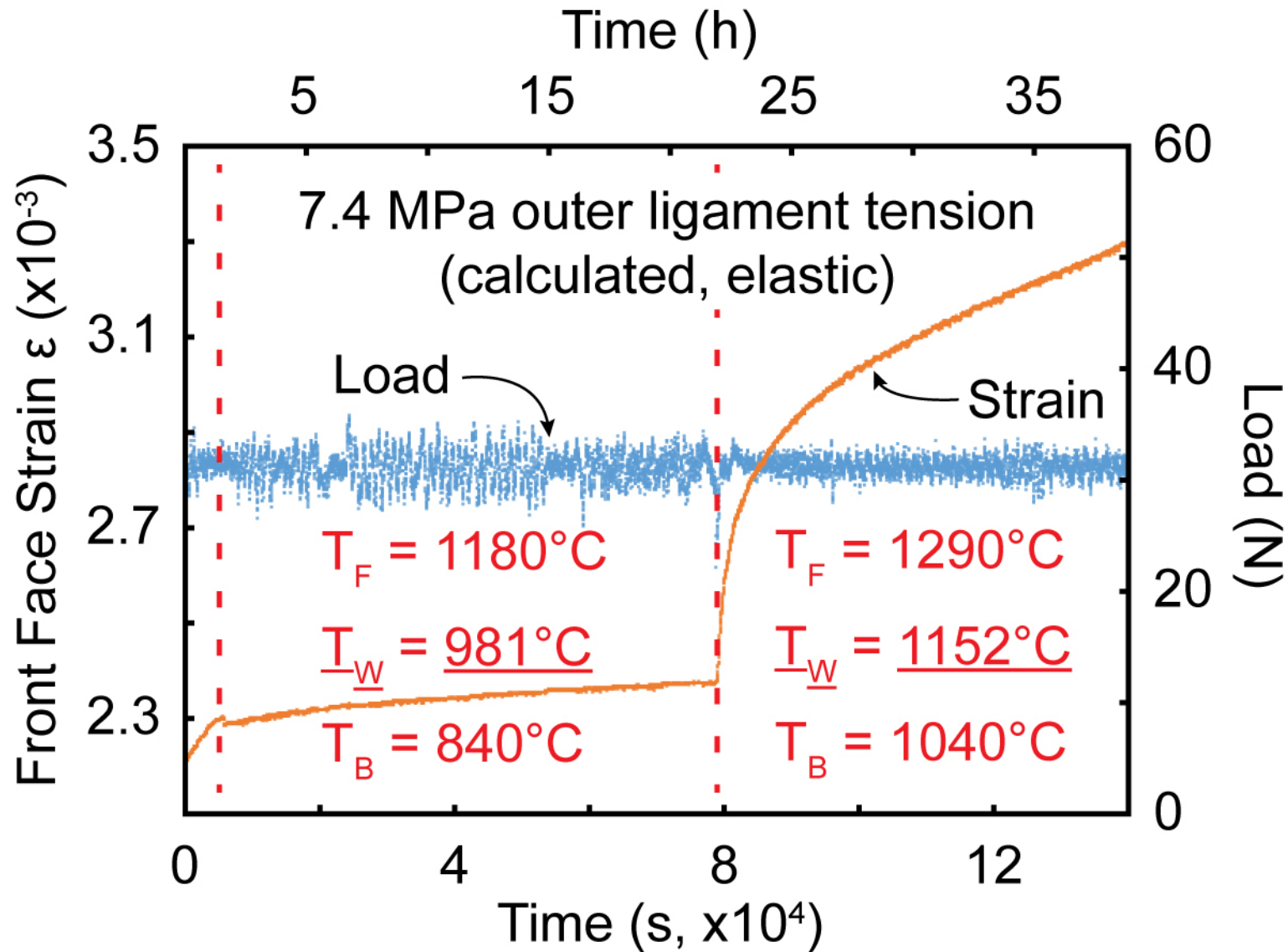
$$E_{a,\text{secondary}} = 134.7 \text{ kJ/mol with } R^2 = 0.98$$

$$E_{a,\text{primary}} = 127.2 \text{ kJ/mol with } R^2 = 0.94$$

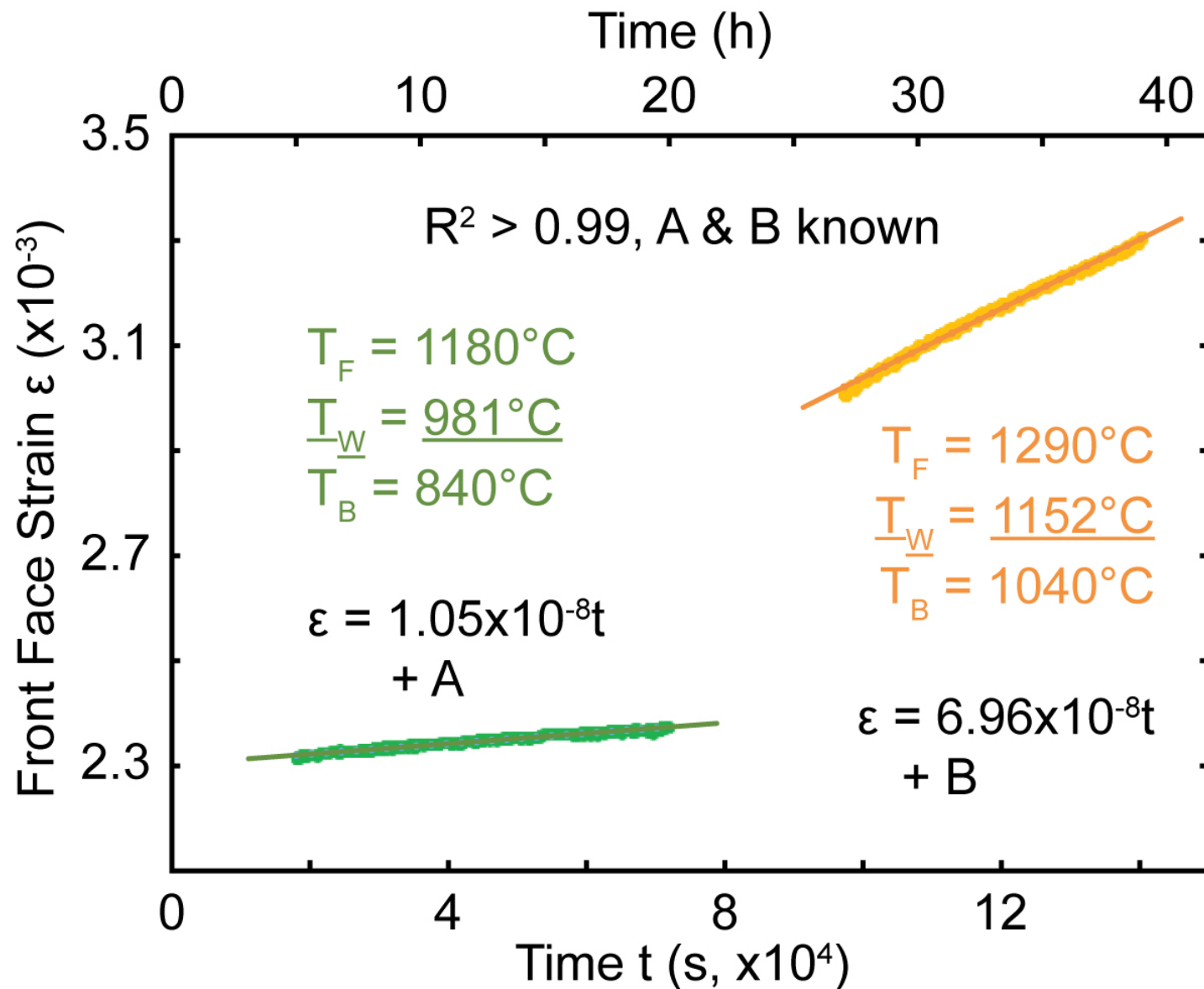
For reference (see Zhu et. Al. 1999):

$$E_a \text{ for 10\% porous APS YSZ} = 105 \text{ kJ/mol}$$

Laser Thermal Gradient Creep Behavior



Thermal Gradient Creep Behavior (T)





Creep Activation Energies

Isothermal Secondary Creep Activation Energy

$$E_a = 134.7 \text{ kJ/mol @ } 15.8 \text{ Mpa}$$

Laser Gradient Secondary Creep Activation Energy

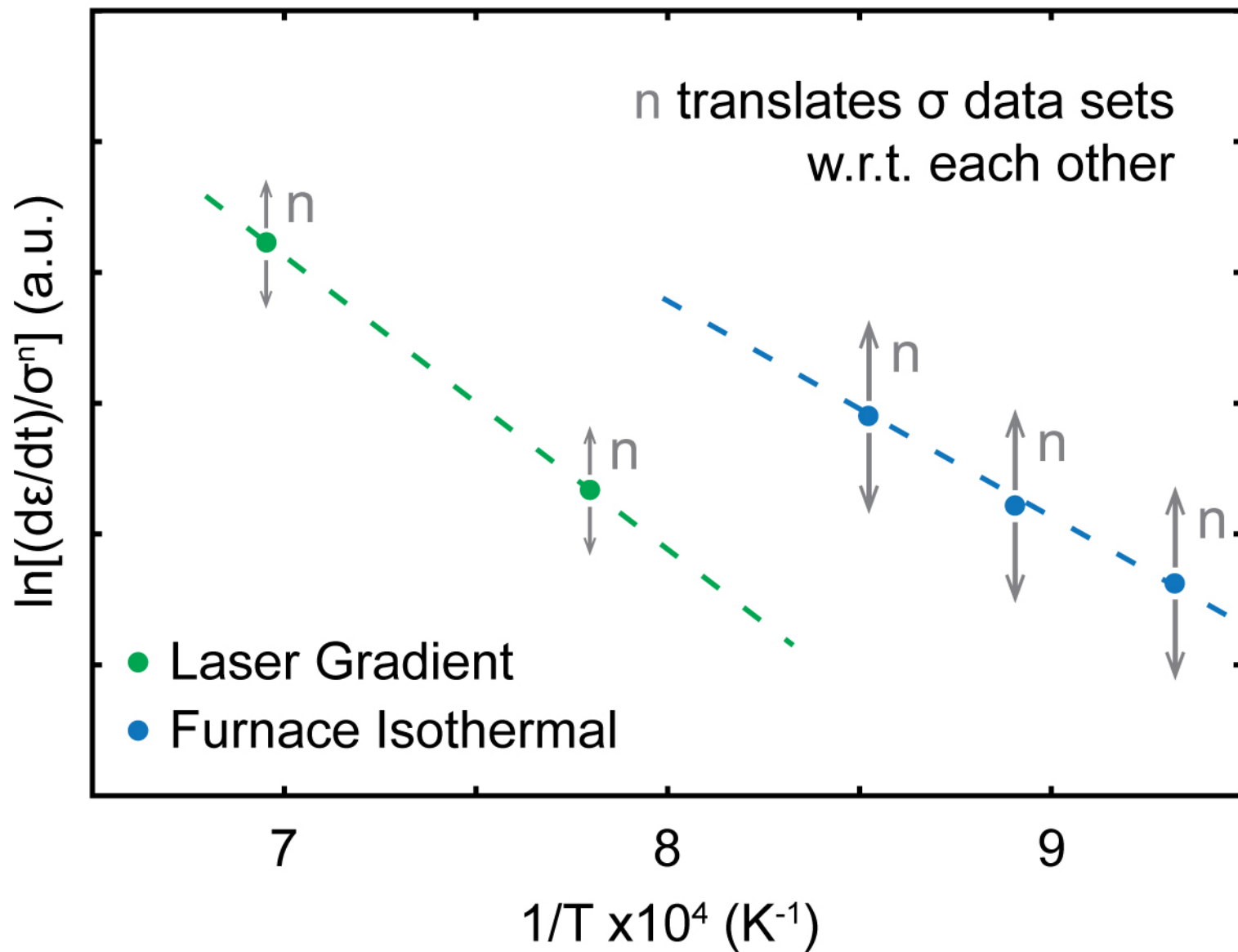
$$E_a = 165.4 \text{ kJ/mol @ } 7.4 \text{ Mpa}$$

Data at multiple stresses allows rough approximation of creep n parameter assuming same creep mechanism (same E_a).

n will be a rough estimate!!! More detailed determination of n with isothermal data in progress.

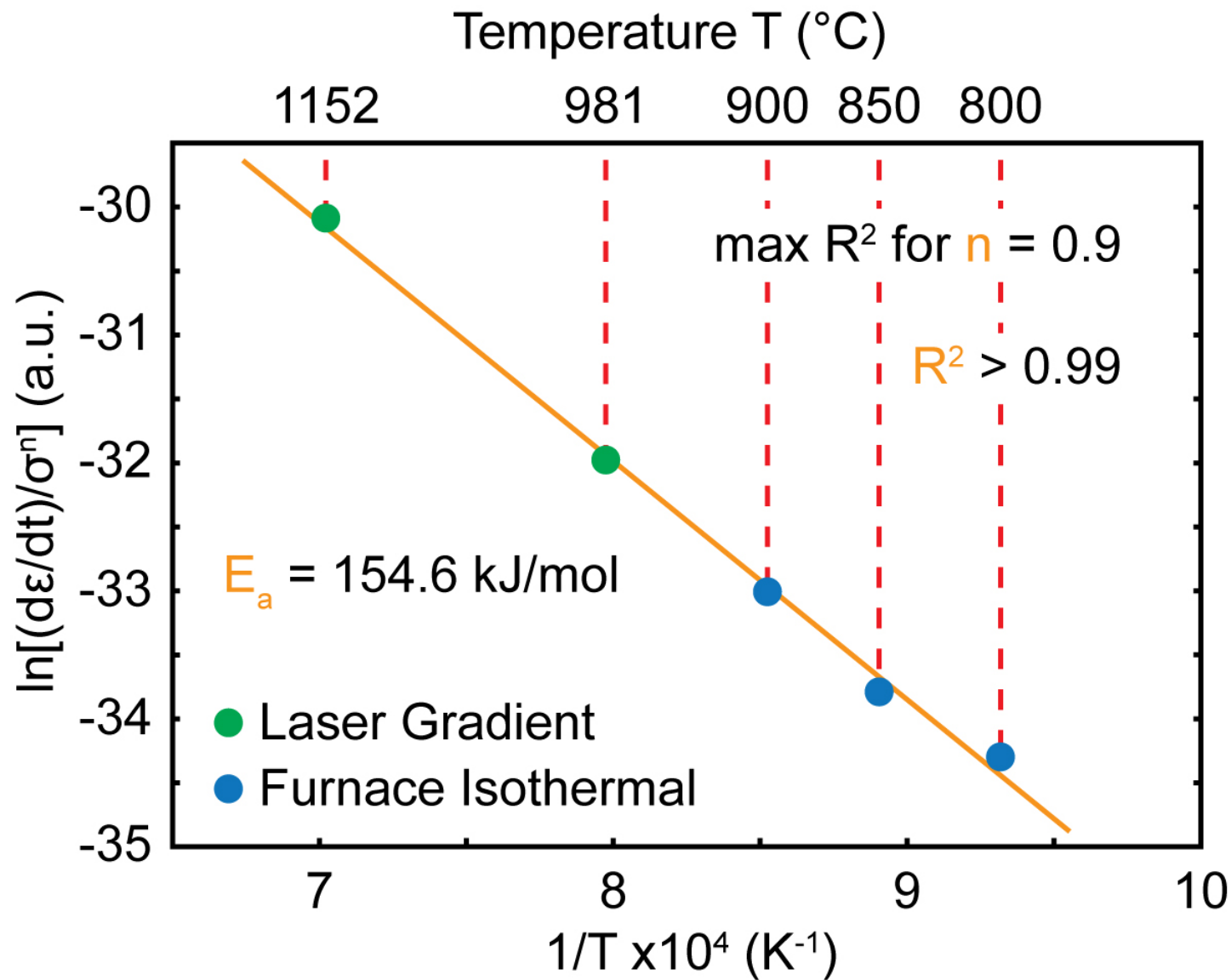


Effect of n





n and E_a determinations





APS $\text{Yb}_2\text{Si}_2\text{O}_7$ Properties Summary

$E = 33.4 \text{ GPa}$ ($\sim 180 \text{ GPa}$ bulk- X-ray, nanoindentation)

$K_{IC} = 0.925 \text{ MPa}\cdot\text{m}^{0.5}$

Low T Flexure Strength = 19.7 Mpa ($\sim 100 \text{ MPa}$ for dense, stoichiometric $\text{Yb}_2\text{Si}_2\text{O}_7$, $\sim 15 \text{ MPa}$ for Yb_2SiO_5)

High T Flexure Strength = 24.3 Mpa

$d\varepsilon/dt = 3.39 \times 10^{-9} \text{ @ } 800^\circ\text{C}$ (isothermal)

$d\varepsilon/dt = 6.96 \times 10^{-8} \text{ @ } 1152^\circ\text{C}$ (laser gradient)

$s = 0.78$ (comparable to APS YSZ)

$n = \sim 0.9$ ($n = 1$ for diffusional)

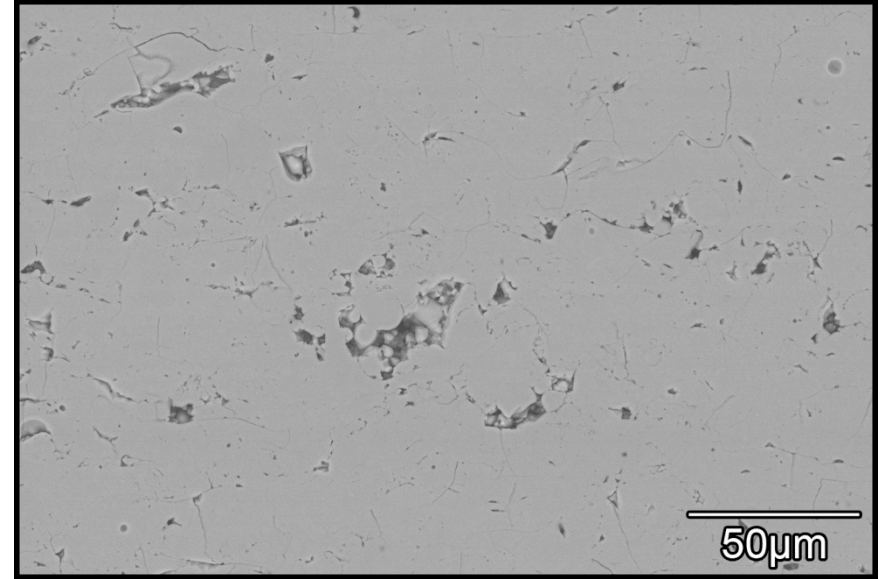
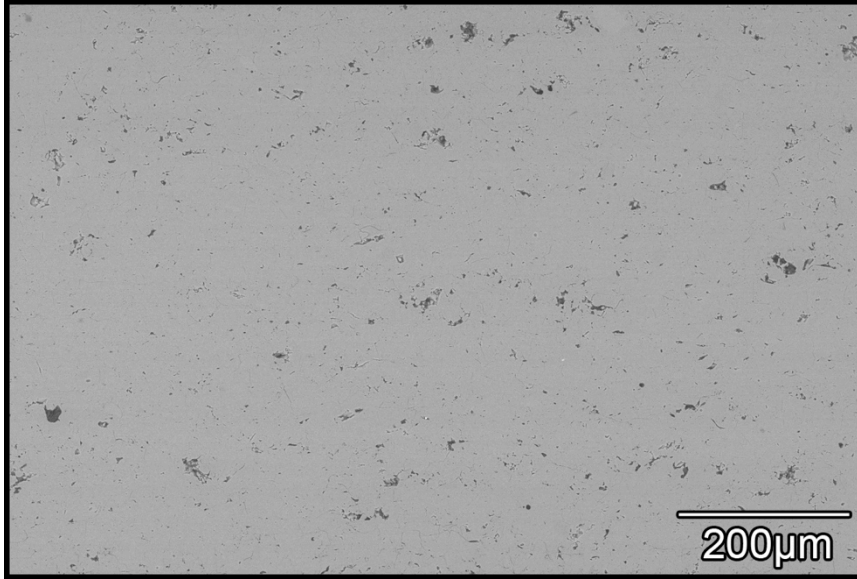
$E_a = 135\text{-}165 \text{ kJ/mol}$



APS Silicon Properties

Elastic Modulus, Flexure Strength, Toughness, Laser
Thermal Gradient Creep, Interface Toughness

Si Microstructure



Plasma sprayed structure is crack-free and 95+% dense
(archimedes density and image analysis)



APS Si Properties (uncoated)

- Elastic Modulus- impulse excitation $E = 73.0 \text{ GPa}$, $\sigma = 2.12$
9 specimens @ 25°C

($E = 163 \text{ GPa}$ for pure, dense polycrystal)^a

- Low Temperature $K_{IC} = 1.54 \text{ MPa}\cdot\text{m}^{0.5}$, $\sigma = 0.05$
4 specimens @ 25°C

($0.8\text{-}0.9 \text{ MPa}\cdot\text{m}^{0.5}$)^a

- Low Temperature Flexure Strength = 76.6 MPa , $\sigma = 1.32$
5 specimens @ 25°C

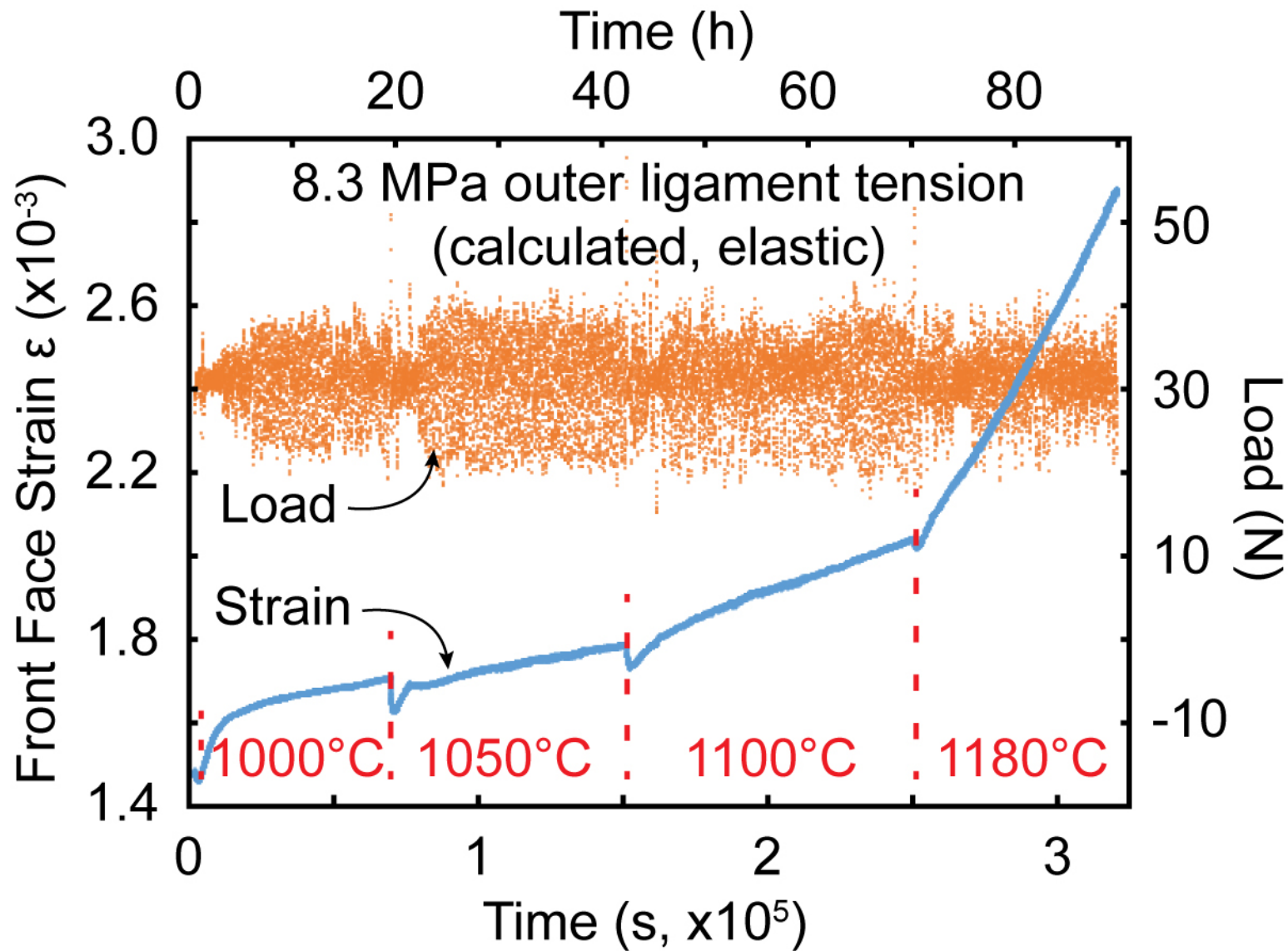
(260 MPa polished polycrystal, very high scatter)^a

- High Temperature Flexure Strength = 186.8 MPa , $\sigma = 24.2$
2 specimens @ 900°C

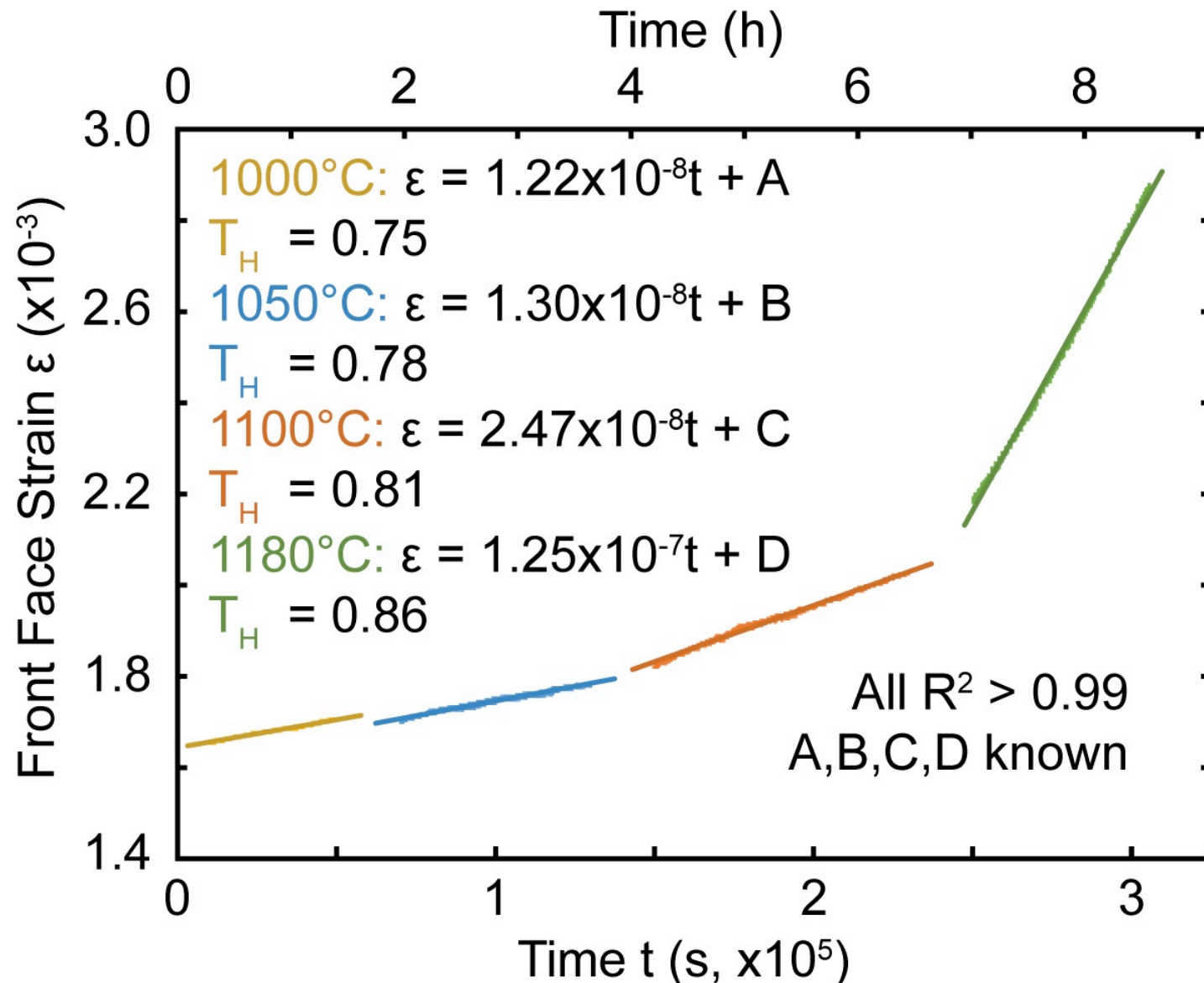
(500 MPa polished polycrystal, very high scatter)^a

^aHull, 1999

4 T YbS₂-coated laser thermal gradient creep

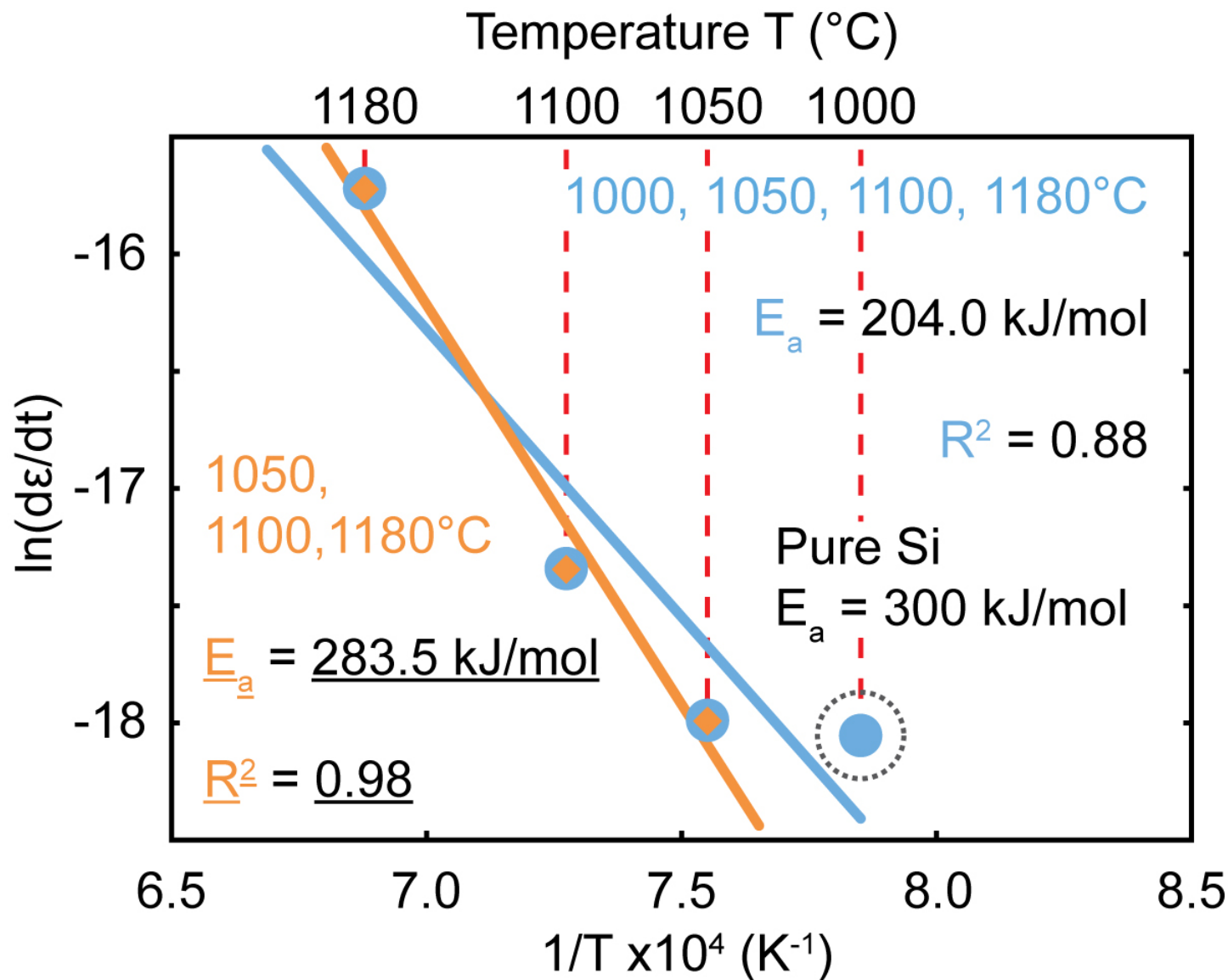


Gradient Creep Behavior at Different T





E_a calculation for APS Si





Laser Gradient Creep Rates and E_a

Isothermal Secondary Creep Strain Rates (mechanical affect of 200 μ m YbS₂ not considered):

$$d\varepsilon/dt = 1.22 \times 10^{-8} \text{ @ } 1000^\circ\text{C}$$

$$d\varepsilon/dt = 1.29 \times 10^{-8} \text{ @ } 1050^\circ\text{C}$$

$$d\varepsilon/dt = 2.47 \times 10^{-8} \text{ @ } 1100^\circ\text{C}$$

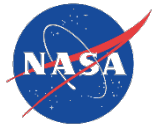
$$d\varepsilon/dt = 1.25 \times 10^{-7} \text{ @ } 1180^\circ\text{C}$$

**1000°C data may be suspect/ different creep regime*

Isothermal Secondary Creep Activation Energy

$$E_a = 283.5 \text{ kJ/mol with } R^2 > 0.98 \text{ (bulk 300 kJ/mol)}$$

(1050, 1100, 1180°C data)



APS Si Properties Summary

$E = 73.0 \text{ GPa}$ (163 GPa bulk)

$K_{IC} = 1.54 \text{ MPa}\cdot\text{m}^{0.5}$ (0.8-0.9 MPa $\cdot\text{m}^{0.5}$)

Low T Flexure Strength = 76.6 Mpa (~260MPa bulk)

High T Flexure Strength = 186.6 Mpa (~500MPa bulk)

$d\varepsilon/dt = 1.29 \times 10^{-8}$ @ 1050°C (laser gradient)

$d\varepsilon/dt = 1.25 \times 10^{-7}$ @ 1180°C (laser gradient)

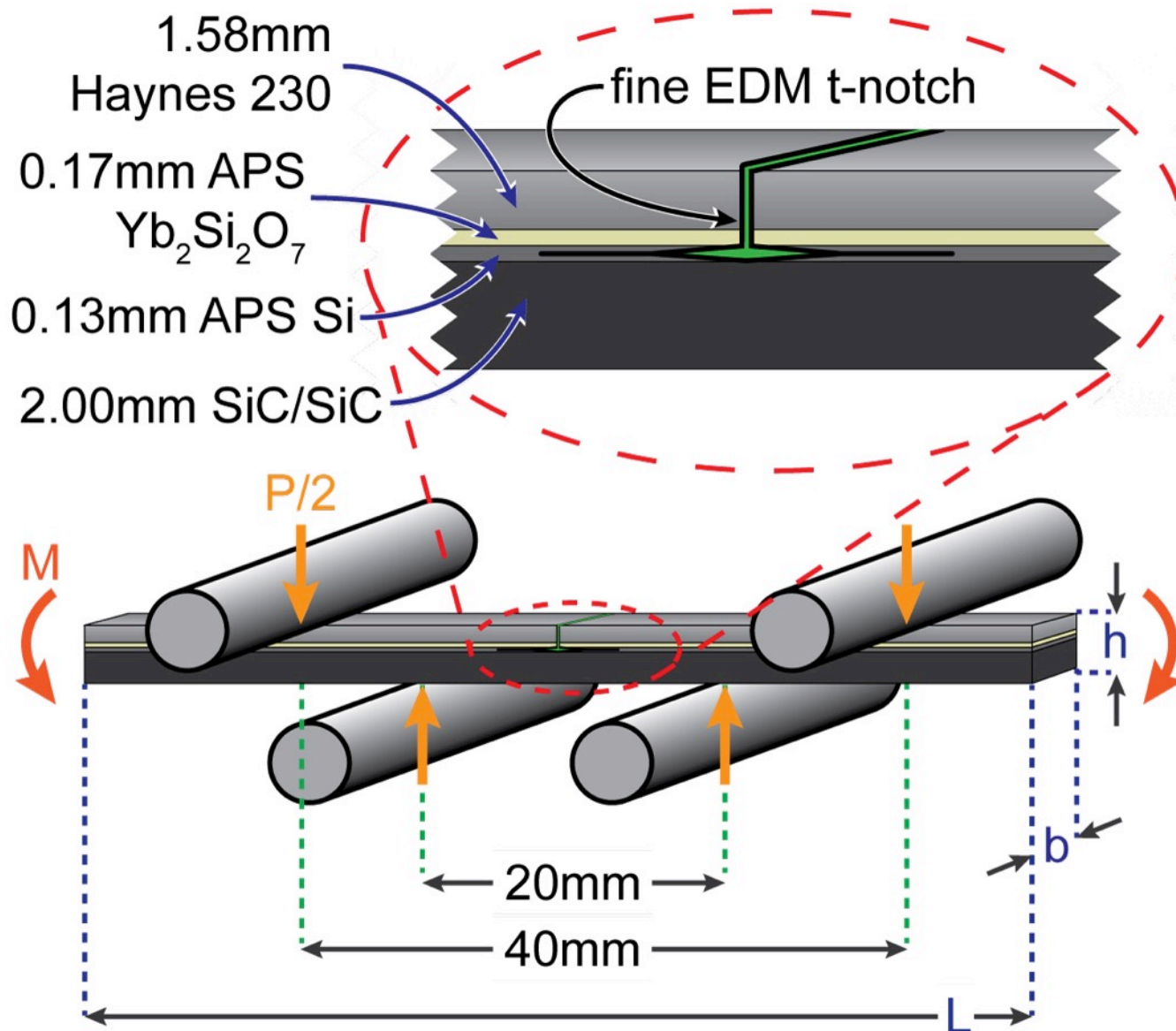
$E_a = 283.5 \text{ kJ/mol}$ (300 kJ/mol bulk)

*Increase in K_{IC} may be due to crack blunting, splat boundary SiO_2 , reduced modulus, etc.



Interlaminar (interfacial) Toughness

4-point bend testing of cracked specimens



EBC
Interfacial/
interlaminar
toughness
studies:

4-point
bending t-
notched
configuration

FEM modeled fracture solutions

Stress Intensity Factors

$$F_I(a) = K_I BW^{3/2}/(P(S_o-S_i))$$

$$F_{II}(a) = K_{II} BW^{3/2}/(P(S_o-S_i))$$

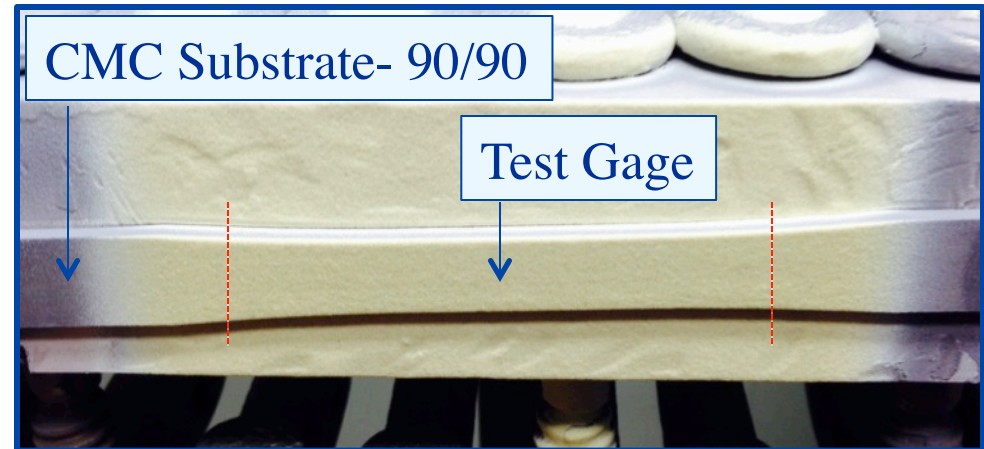
Strain Energy Release Rate

$$G(a) = K_I^2(1-\nu^2)/E + K_{II}^2(1-\nu^2)/E$$

$$G_N = GP(S_o-S_i)/(BW^2)$$

Mode Mixity Angle

$$\phi = \text{atan}(K_{II}/K_I)$$

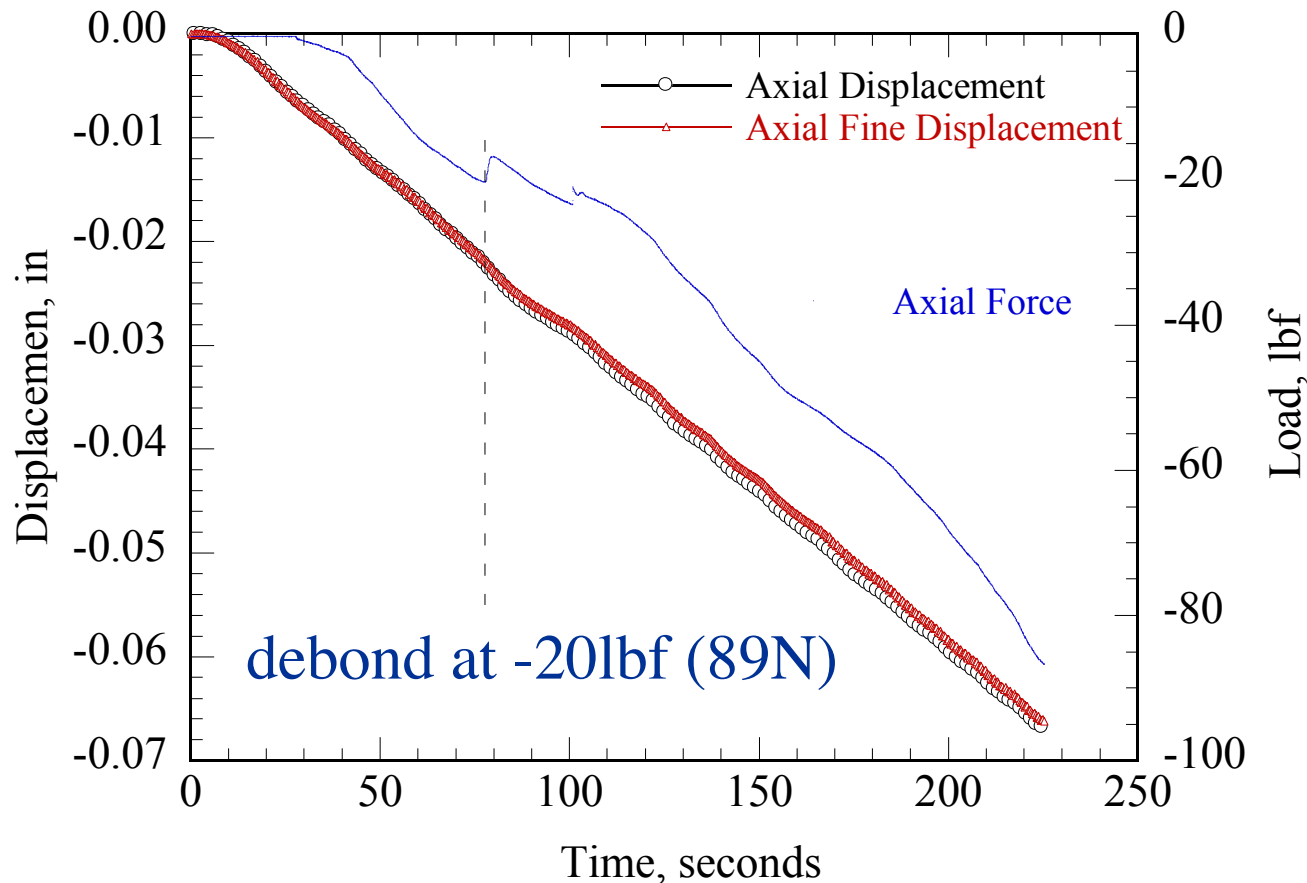


Air Plasma Sprayed CMC
prior to stiffener bonding &
test form machining

a/2 mm	a/Si	KI-norm	KII-Norm	Angle, deg	G-Norm
2	0.1	1.07	0.59	29.10	4.89E-05

Data used in calculations

Example Test on T-cracked Specimen crack appears to kink into Si-SiC interface



At -20 lbf (89 N)

$$K_I = 1.576 \text{ MPa} \cdot \text{m}^{0.5}$$

$$K_{II} = 0.869 \text{ MPa} \cdot \text{m}^{0.5}$$

At -22 lbf (98 N)

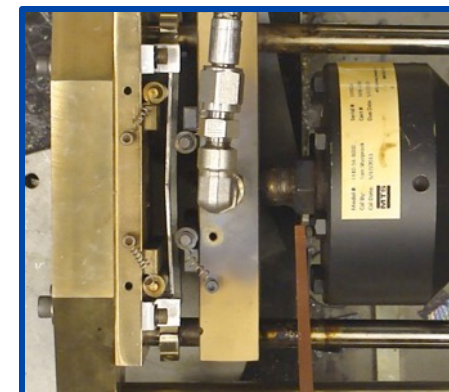
$$K_I = 1.733 \text{ MPa} \cdot \text{m}^{0.5}$$

$$K_{II} = 0.956 \text{ MPa} \cdot \text{m}^{0.5}$$

Debonded in load frame



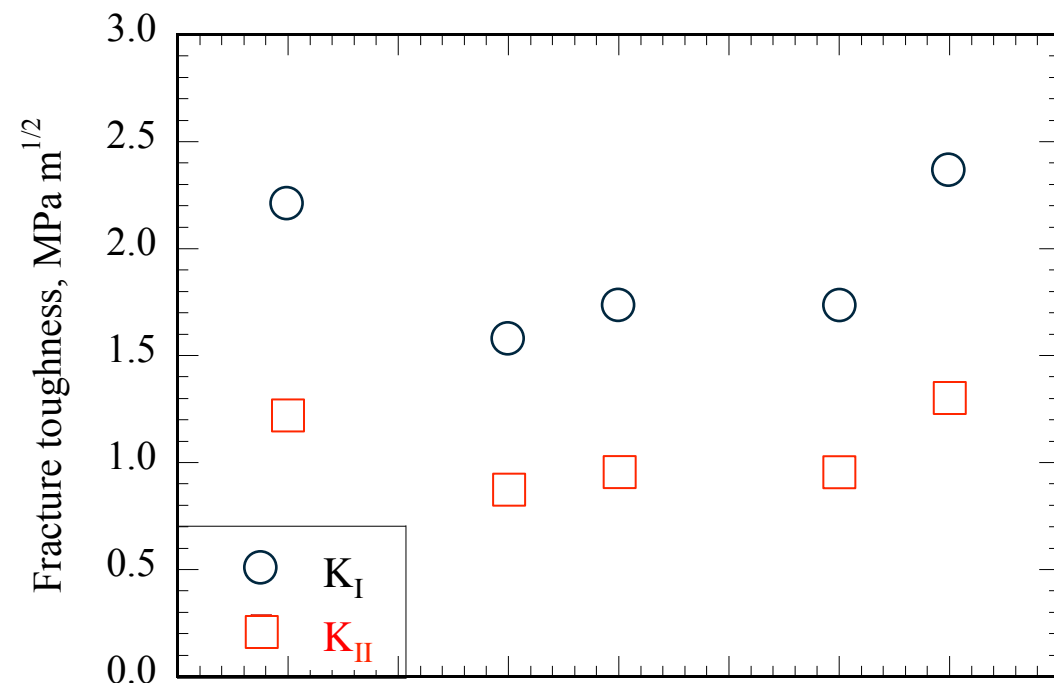
After test





EBC Interlaminar Toughness Results

Measured $K_I = 1.92 \text{ MPa}\cdot\text{m}^{0.5}$ and $K_{II} = 1.06 \text{ MPa}\cdot\text{m}^{0.5}$ at $\phi = 29.10^\circ$ and critical load (i.e. G_C achieved)- calculated using FEM solutions presented.

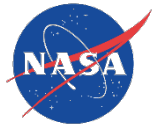


	K1	KII
Min	1.58	0.87
Max	2.36	1.30
Mean	1.92	1.06
Std Dev	0.34	0.188



Conclusions

1. Elastic Moduli and Flexure Strength of APS EBC materials are low, but comparable to data published for APS TBC materials
2. Fracture toughness of APS materials is comparable to toughness of bulk materials
3. Creep rates of EBC materials appear high and activation energies for YbS₂ are low- creep is likely a surface diffusion based process
4. Interlaminar toughness measurements are possible using a stiffener-modified 4-point bend test; Si-SiC interface toughnesses have been measured and appear comparable to Si



Acknowledgements and Questions

Ralph Pawlik (NASA GRC)- mechanical testing of materials

Jeroen Deijkers and Hengbei Zhao (UvA)- lab assistance

NASA support under the Fundamental Aeronautics Program

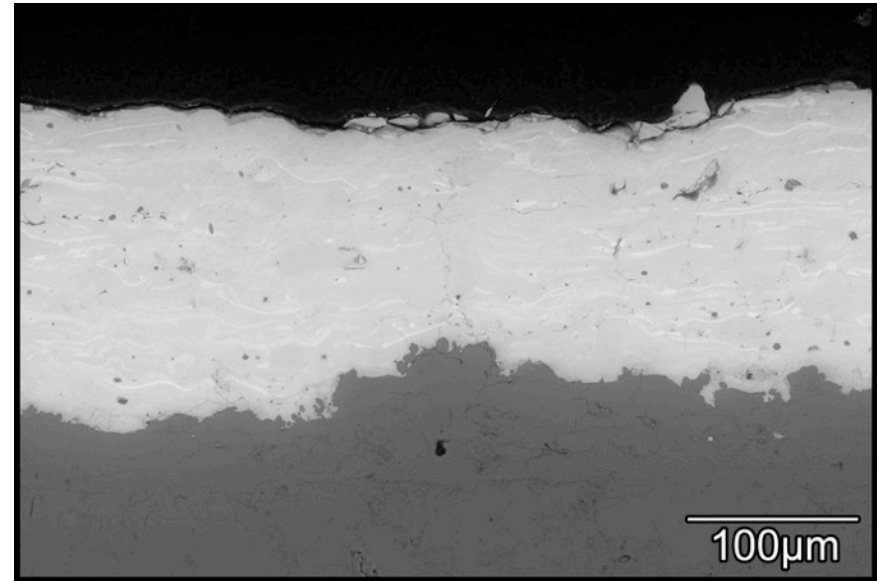
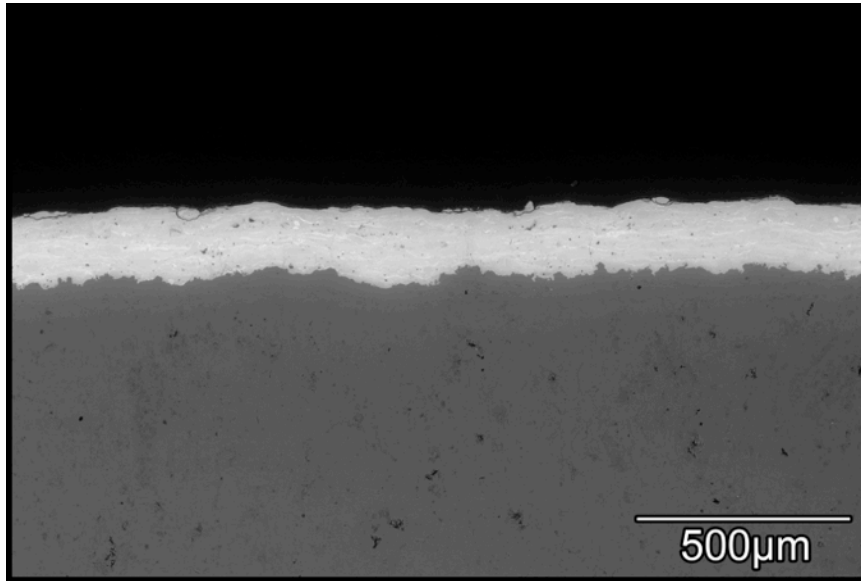
Uva support from the Office of Naval Research under grant N00014-11-1-0917 managed by Dr. David Shifler



Backup Slides

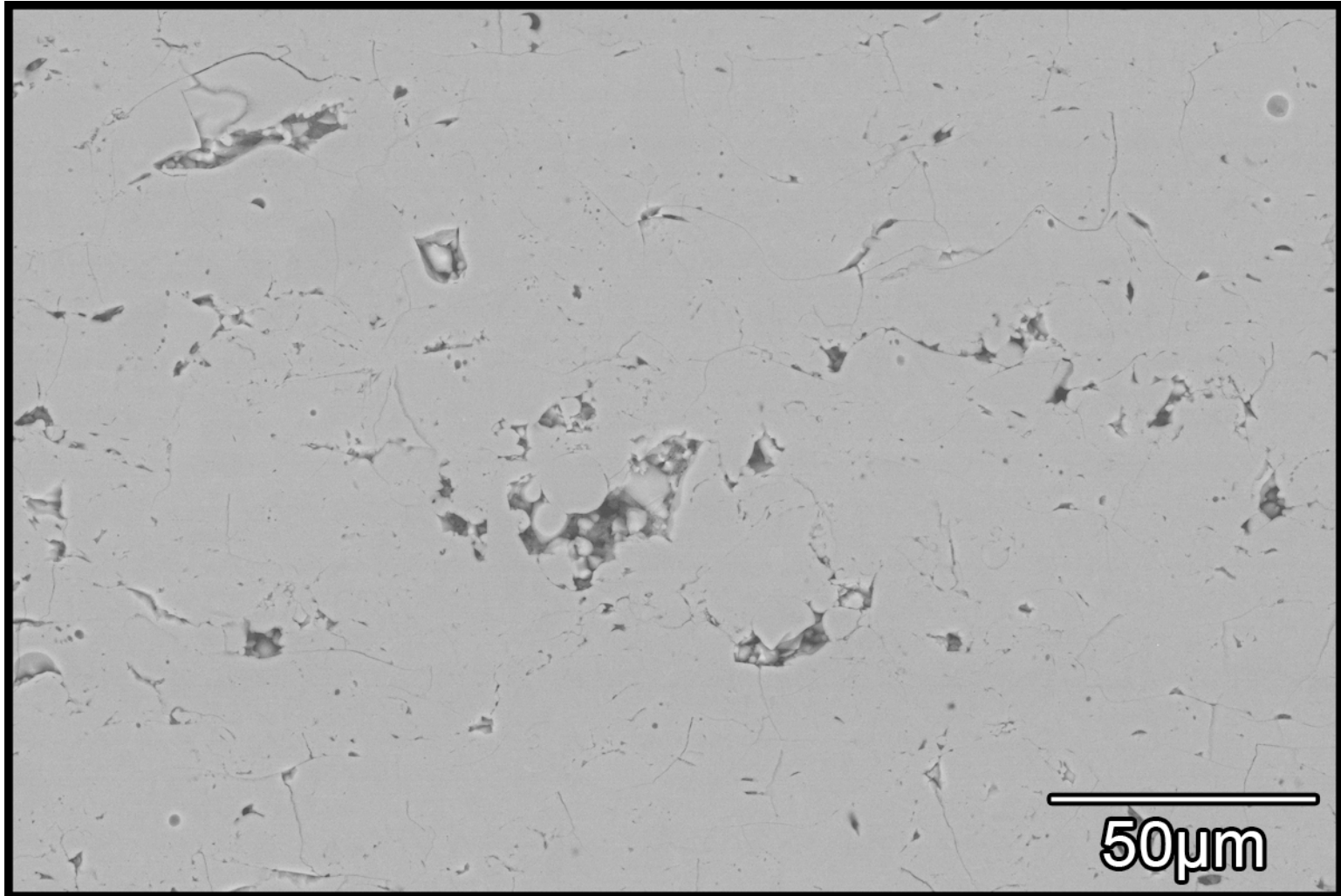
(and Appendix-type data)

Si Microstructure



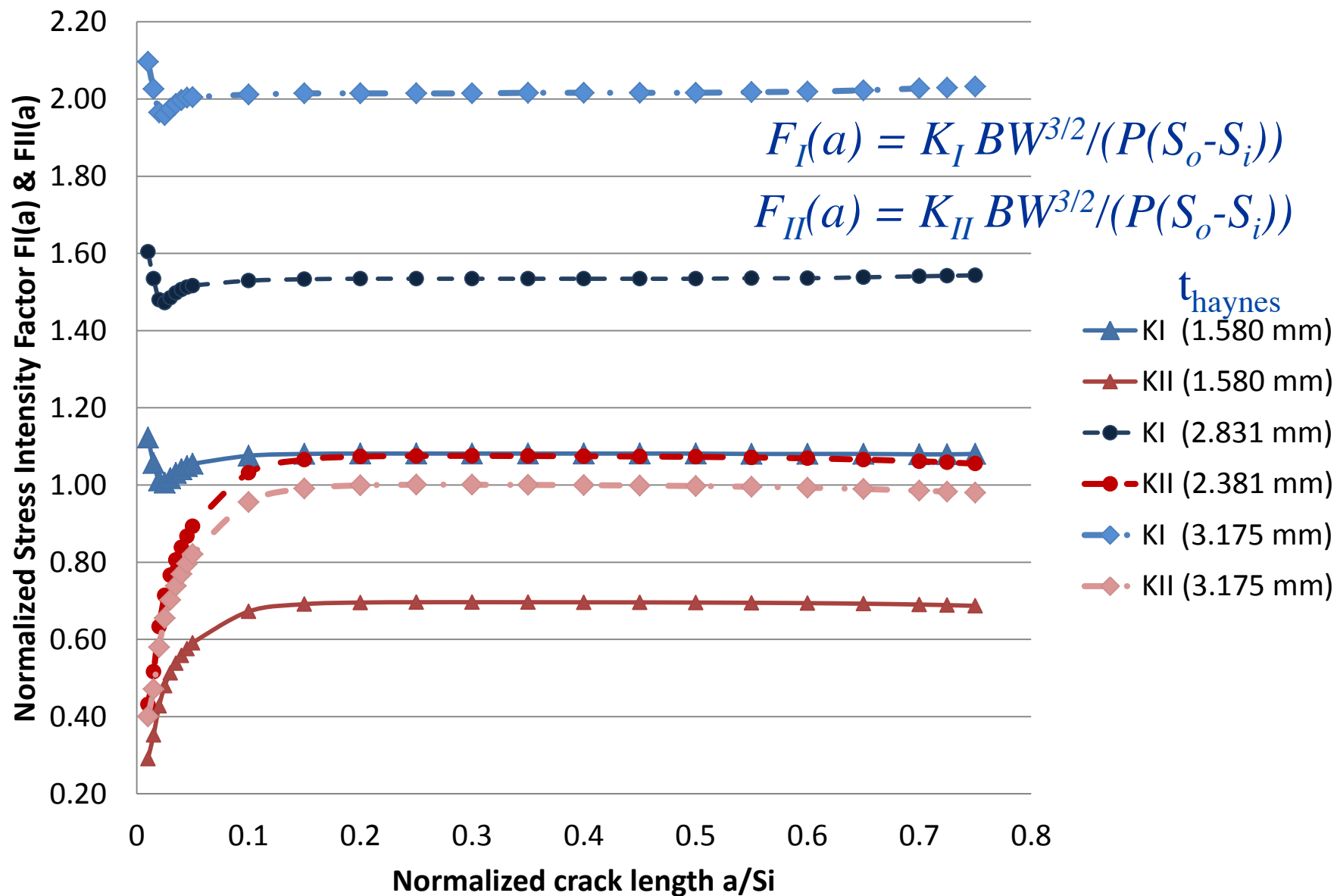
Plasma sprayed structure is crack-free and 94-95% dense (archimedes density and image analysis)

Higher Magnification APS Si



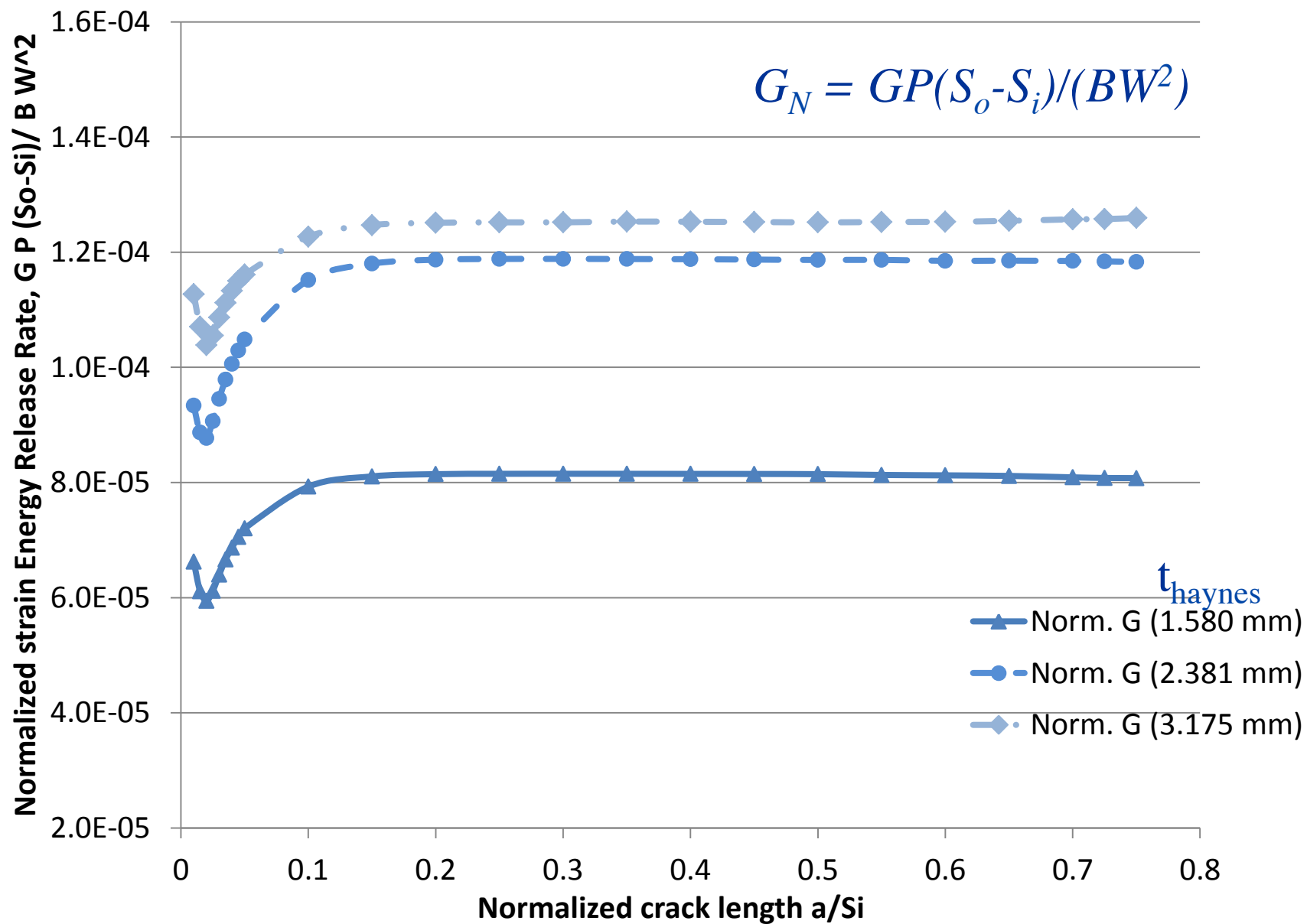


Normalized Stress Intensity Factor



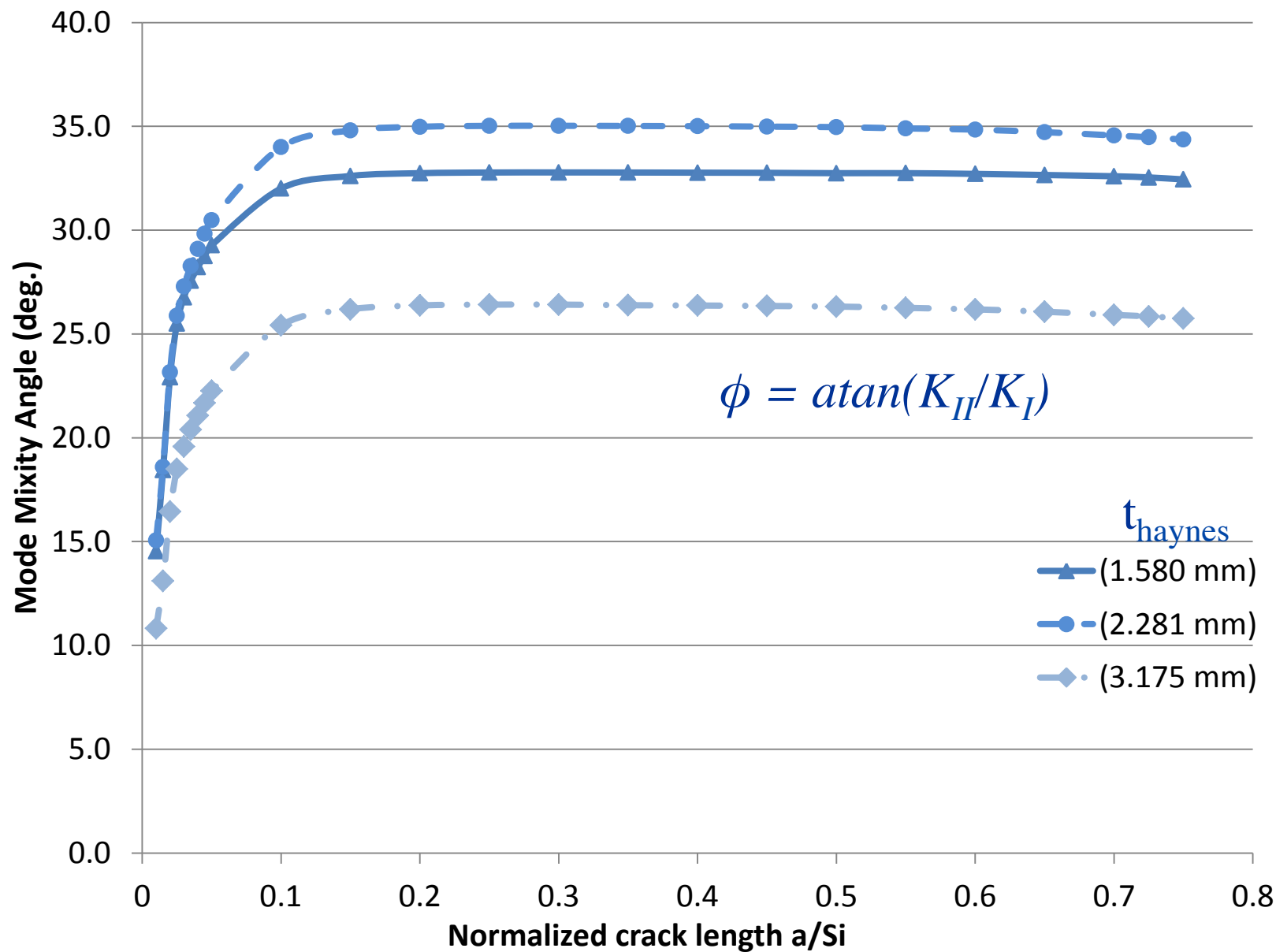


Normalized Strain Energy Release Rate



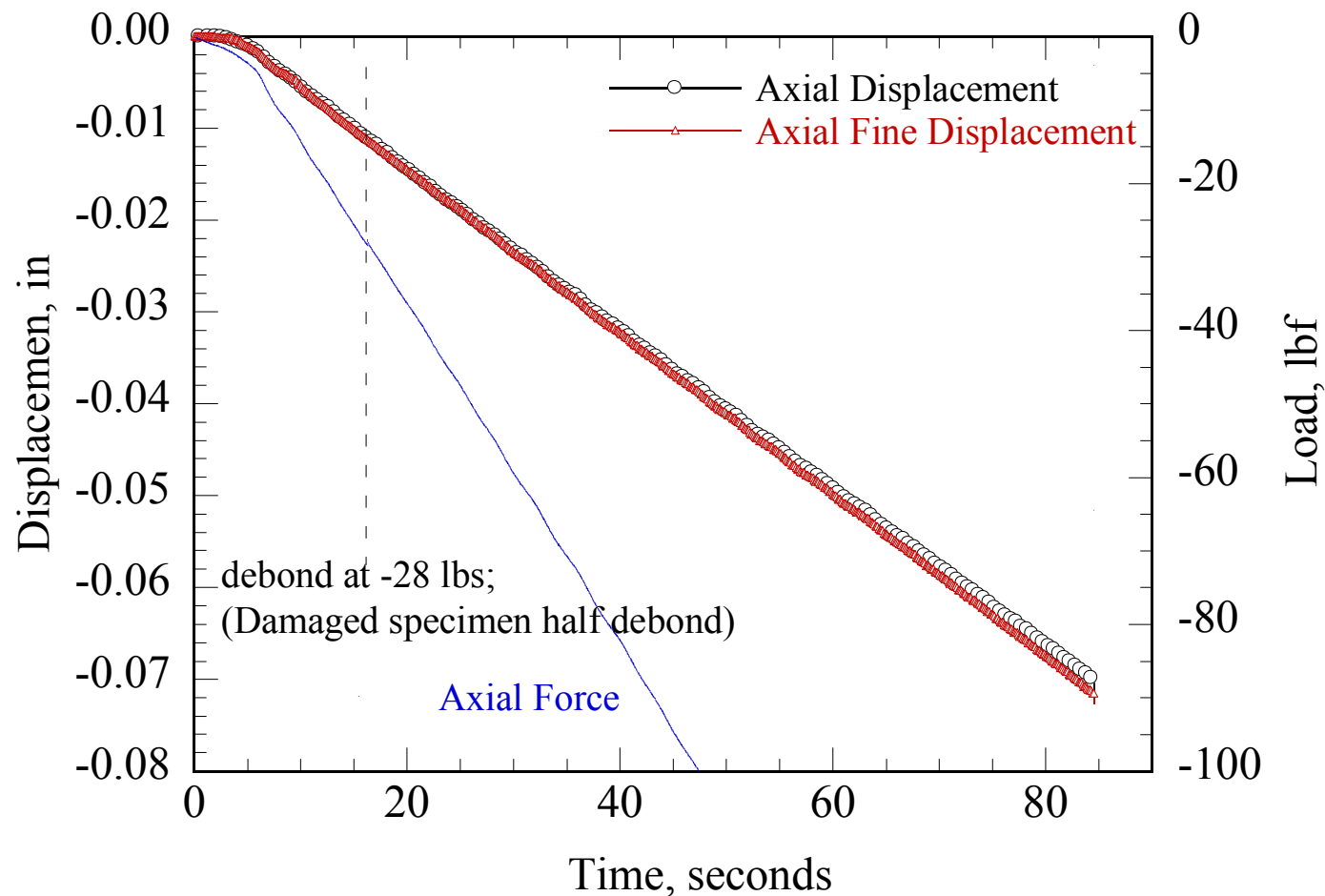


Mode Mixity Angle



EBC Interlaminar Strength Test - 114-93-7-#13

- 114-93-7-#13 specimen, failure load at -28 lbf



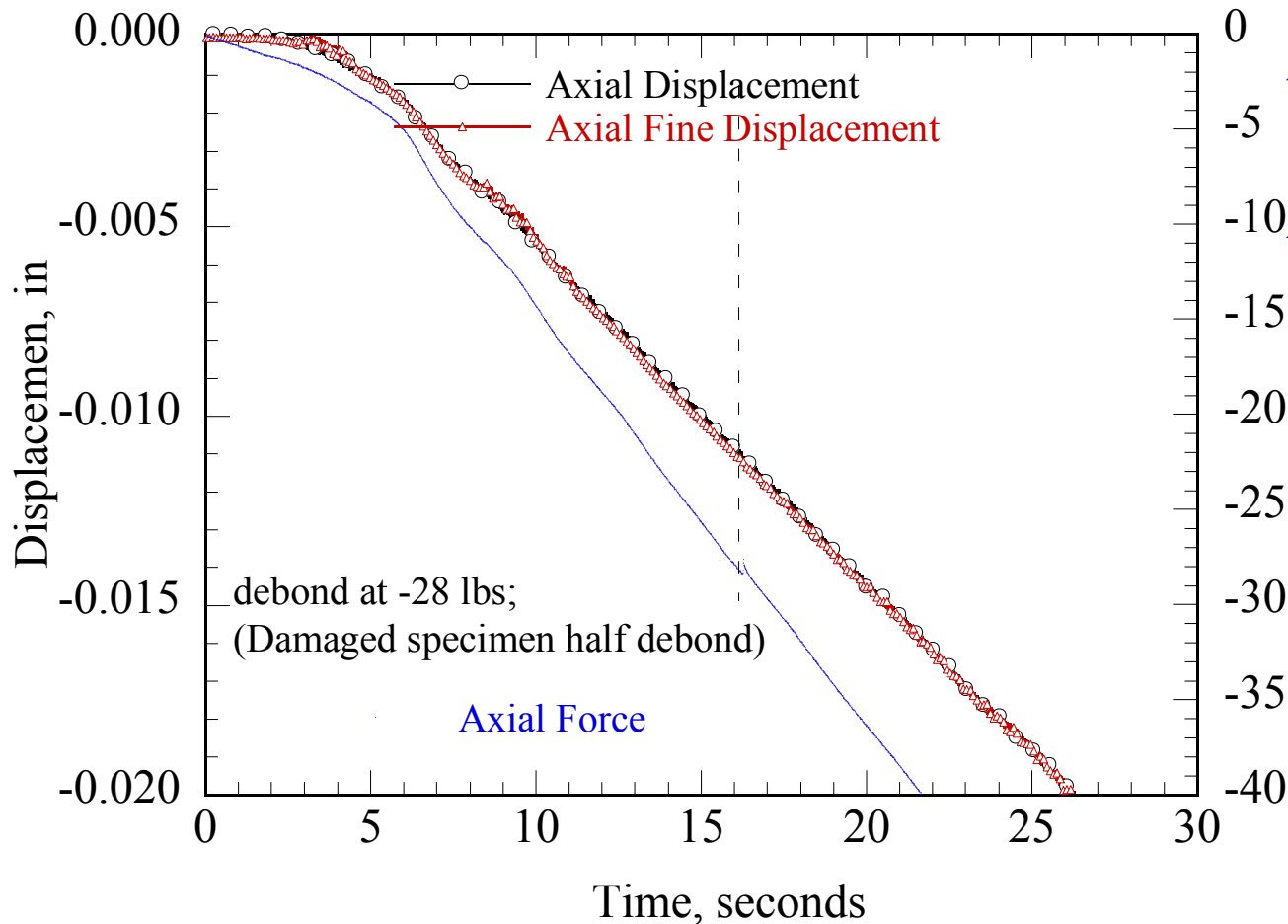
After debond

EBC Interlaminar Strength Test - 114-93-7-#13

Cont'd

- 114-93-7-#13 specimen, failure load at -28 lbf

At -28 lbf (124.578N)

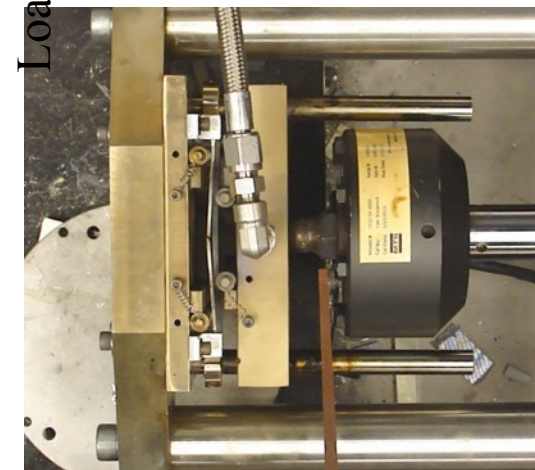


$$K_I = \frac{F_I(a)P(S_o - S_i)}{B W^{3/2}} = \frac{1.07 * 124.578 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2}}$$

$$K_I = 2.206 \text{ MPa} * m^{0.5}$$

$$K_{II} = \frac{F_{II}(a)P(S_o - S_i)}{B W^{3/2}} = \frac{0.59 * 124.578 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2}}$$

$$K_{II} = 1.216 \text{ MPa} * m^{0.5}$$



Debond



After test

EBC Interlaminar Strength Test

- 114-93-7-#11 specimen, failure load at -22 and -30 lbf

At -22 lbf (97.882 N)

$$K_I = \frac{F_I(a)P(S_o - S_i)}{B W^{3/2}} = \frac{1.07 * 97.882 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2} * 10^{-6}}$$

$$K_I = 1.733 \text{ MPa} * m^{0.5}$$

$$K_{II} = \frac{F_{II}(a)P(S_o - S_i)}{B W^{3/2}} = \frac{0.59 * 97.882 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2} * 10^{-6}}$$

$$K_{II} = 0.956 \text{ MPa} * m^{0.5}$$

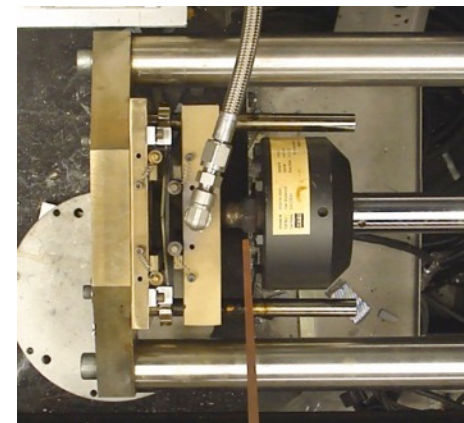
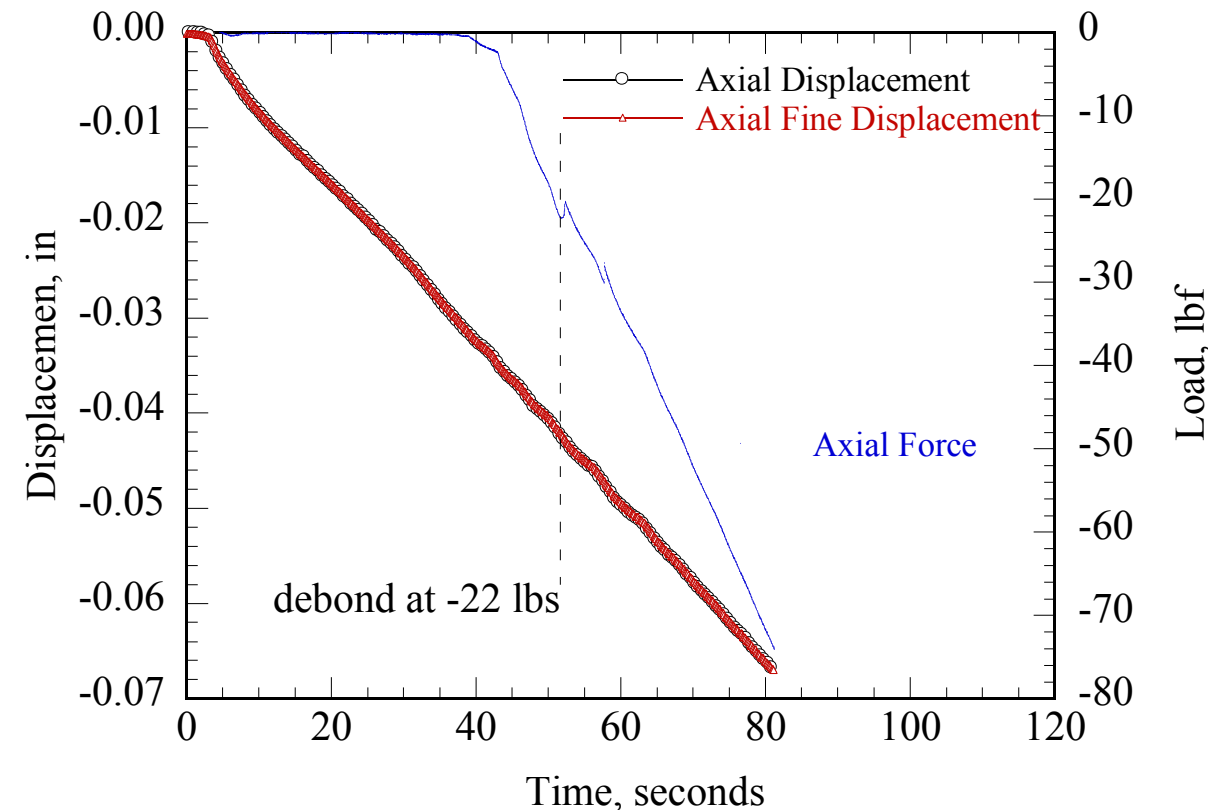
At -30 lbf (133.476 N)

$$K_I = \frac{F_I(a)P(S_o - S_i)}{B W^{3/2}} = \frac{1.07 * 133.476 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2} * 10^{-6}}$$

$$K_I = 2.364 \text{ MPa} * m^{0.5}$$

$$K_{II} = \frac{F_{II}(a)P(S_o - S_i)}{B W^{3/2}} = \frac{0.59 * 133.476 * 40 * 10^{-3}}{(10 * 10^{-3}) * (3.88 * 10^{-3})^{3/2} * 10^{-6}}$$

$$K_{II} = 1.303 \text{ MPa} * m^{0.5}$$



Debond